



Obducat receives order for an EITRE[®] 6 NIL-system from a University in China

OBDUCAT AB (publ) subsidiary Obducat Technologies AB, a leading supplier of system solutions for lithography processing, has received an order from a University in China, for the supply of a EITRE 6 system. The order value amounts to approx. 2 million SEK.

The EITRE 6 system will be installed in the cleanroom facilities of the University. The system will be used in building up a university-level micro-nano fabrication and testing platform and perform state-of-the-art research on semiconductor materials and devices, optoelectronic materials and devices, MEMS technologies, and IC chip packaging technologies. The facility is also opened to the research groups outside the University.

The EITRE 6 system is planned to be delivered in the fourth quarter this year.

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About Obducat AB (publ)

Obducat AB (publ) is an innovative developer and supplier of technologies, products and processes used for the production and replication of advanced micro and nano structures. Obducat's products and services serve the demands of companies within the LED, OLED, semiconductor, displays, biomedical and MEMS industries. Obducat's technologies include nano imprint technology, coating technology and wet processing technology. Obducat has offices in Sweden, Germany and China and the headquarter is located in Lund, Sweden. Obducat's class B shares and preferential class B shares are publicly traded on the Swedish NGM Equity stock exchange. Read more at www.obducat.com.